Title: Using high numerical aperture objective lens in micro-reflectance difference spectrometer

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- Investigating the anisotropic effect of high NA objective lens through mathematical approaches of vectorial ray-tracing method and Debye-Wolf integral.
- A micro-RDS based on liquid crystal variable retarder (LCVR) in the visible range was built.
- An in-situ calibration method was presented to effectively suppress the most easily induced asymmetric error.
- The broad band RD spectroscopy of black phosphorus film on Si/SiO2 substrate was obtained.